Docket No.

209294US-

IN THE UNICED STANZES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Takahisa KIKUCHI

SERIAL NUMBER: 09/867,464

ATTN: APPLICATION BRANCH

FILING DATE:

May 31, 2001

FOR:

EVALUATION METHOD, POSITION DETECTION METHOD, EXPOSURE METHOD AND DEVICE

MANUFACTURING METHOD, AND EXPOSURE APPARATUS

FILING OF DECLARATION UNDER 37 CFR 1.53(f)

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

Responsive to the notification dated August 13, 2001, and in accordance with the provisions of 37 CFR 1.53(f), Applicants submit herewith a Rule 63 Declaration.

The required fee was paid at the time of filing the application.

In light of the foregoing, this application is deemed to be in proper condition for examination and such favorable action is earnestly solicited.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

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